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_	APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	۰
_	10/722,179	11/25/2003	Kamal Kishore Goundar	ASMJP.133CP1	7004	-
	20995	7590 11/21/2005		EXAMINER		
	KNOBBE MARTENS OLSON & BEAR LLP 2040 MAIN STREET			ANYA, IGWE U		
	FOURTEENT			ART UNIT	PAPER NUMBER]
	IRVINE, CA			2891		•

DATE MAILED: 11/21/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

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Supplemental Notice of Allowability

Application No.	Applicant(s)		
10/722,179	GOUNDAR ET AL.		
Examiner	Art Unit		
Igwe U. Anya	2891		

·.	Igwe U. Anya	2891				
The MAILING DATE of this communication appear All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this app or other appropriate communication GHTS. This application is subject to	plication. If not include will be mailed in due	ed course. THIS			
1. This communication is responsive to	•					
2. The allowed claim(s) is/are						
3. Acknowledgment is made of a claim for foreign priority una) All b) Some* c) None of the:	nder 35 U.S.C. § 119(a)-(d) or (f).					
 Certified copies of the priority documents have 	been received.					
2. Certified copies of the priority documents have	been received in Application No	·				
Copies of the certified copies of the priority documents of the priority documents of the priority documents of the certified copies not received: * Certified copies not received:	cuments have been received in this	national stage applica	tion from the			
* Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.						
4. A SUBSTITUTE OATH OR DECLARATION must be subminFORMAL PATENT APPLICATION (PTO-152) which give			OTICE OF			
5. CORRECTED DRAWINGS (as "replacement sheets") mus	t be submitted.					
(a) ☐ including changes required by the Notice of Draftspers		948) attached	1			
1) ☐ hereto or 2) ☐ to Paper No./Mail Date		•				
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment or in the O	ffice action of				
Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in t	.84(c)) should be written on the drawin he header according to 37 CFR 1.121(c	gs in the front (not the i).	back) of			
6. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT	sit of BIOLOGICAL MATERIAL n FOR THE DEPOSIT OF BIOLOGIC	nust be submitted. N AL MATERIAL.	Note the			
Attachment(s) 1. ☐ Notice of References Cited (PTO-892)	5. ☐ Notice of Informal P	atent Application (PT)) 152\			
Notice of Praftperson's Patent Drawing Review (PTO-948)	6. Interview Summary		J- 102)			
	Paper No./Mail Date	ė , ^r				
 Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 	8), 7. 🛛 Examiner's Amendn	renv Comment				
4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. Examiner's Stateme	nt of Reasons for Allo	wance			
	9. Other	•				
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EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

- 2. Authorization for this examiner's amendment was given in a telephone interview with attorney on record Katsuhiro Arai on November 16, 2005.
- 3. The application has been amended as follows:

in claim 40 line 2 delete "formed according to claim 30", replace with --silicon carbide films, each formed by plasma CVD comprising the steps of:

- (A) introducing a raw material gas containing silicon, carbon, hydrogen, a hydrogen gas source, and an inert gas at a predetermined mixing formulation of the raw material gas, the hydrogen source gas, and the inert gas in a reaction chamber;
- (B) applying radio-frequency power to a reaction zone inside the reaction chamber at the mixing formulation, thereby a curable silicon carbide film on the semiconductor substrate; and
- (C) continuously applying radio-frequency power to the reaction zone at a mixing formulation wherein the hydrogen source gas flow is reduced from that of step (B), thereby curing the silicon carbide film to give a dielectric constant and leakage current lower than those of the curable silicon carbide film.—

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Contact Information

4. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Igwe U. Anya whose telephone number is (571) 272-1887. The examiner can normally be reached on M - F 8:30am - 5:00pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, William B. Baumeister can be reached on (571) 272-1722. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Igwe U. Anya Examiner Art Unit 2891

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November 16, 2005

DAVID ZARNEKE RIMARY, EXAMINER

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